

WEST Search History

DATE: Monday, November 15, 2004

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L13	L12 and rinsing	3
<input type="checkbox"/>	L12	L11 and ozone	4
<input type="checkbox"/>	L11	L10 and ((hydrogen flouride) or HF)	8
		(4695327 or 4974530 or 5055138 or 5120370 or 5181985 or 5232511 or 5234540 or 5235995 or 5244000 or 5248380 or 5308745 or 5378317 or 5415191 or 5464480 or 5503708 or 5520744 or 5632847 or 5647386 or 5658615 or 5705089 or 5714203 or 5749975 or 5776296 or 5803982 or 5858107 or 5896875 or 5911837).pn. and (etching or thinning)	13
<input type="checkbox"/>	L9	L8 and (carrier gas)	3
<input type="checkbox"/>	L8	L7 and etching	33
<input type="checkbox"/>	L7	L6 and ozone	38
<input type="checkbox"/>	L6	L5 and hf	434
<input type="checkbox"/>	L5	L4 and oxidiz\$	1304
<input type="checkbox"/>	L4	L3 and thinning	4234
<input type="checkbox"/>	L3	(silicon wafer) or wafer	123782
<input type="checkbox"/>	L2	6497768.pn.	1
<input type="checkbox"/>	L1	6497768	4

END OF SEARCH HISTORY

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		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L15	L14 and rinsing	4
<input type="checkbox"/>	L14	(5944907 or 5971368 or 6299696 or 20020011257 or 6551409).pn. and (etching or thinning) and ozone and ((hydrogen flouride) or HF)	4
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L13	L12 and rinsing	3
<input type="checkbox"/>	L12	L11 and ozone	4
<input type="checkbox"/>	L11	L10 and ((hydrogen flouride) or HF)	8
<input type="checkbox"/>	L10	(4695327 or 4974530 or 5055138 or 5120370 or 5181985 or 5232511 or 5234540 or 5235995 or 5244000 or 5248380 or 5308745 or 5378317 or 5415191 or 5464480 or 5503708 or 5520744 or 5632847 or 5647386 or 5658615 or 5705089 or 5714203 or 5749975 or 5776296 or 5803982 or 5858107 or 5896875 or 5911837).pn. and (etching or thinning)	13
<input type="checkbox"/>	L9	L8 and (carrier gas)	3
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